

INFORMATION DISCLOSURE CITATION

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| Atty. Docket No. | 04329.2758 | Application No. | Not Yet Assigned |
| Applicant | Tetsuro NAKASUGI | | |
| Filing Date | March 7, 2002 | Group: | Not Yet Assigned |

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| Examiner Initial* | Document Number | Issue Date | Name | Class | Sub Class | Filing Date If Appropriate |
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| <i>JP</i> | 6,147,355 | 11/14/00 | ANDO et al. | <i>—</i> | <i>—</i> | |
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| JPB | NAKASUGI, T. et al., "Charged Beam Exposure Method and Charged Beam Exposure Apparatus", U.S. Application Serial No. 09/465,932, filed on December 17, 1999. |
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| Examiner <i>Jack Berman</i> | Date Considered <i>2/18/04</i> |
| <p>*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p> | |
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